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Jean-Luc Trompette, Laurent Massot, Hugues Vergnes. Influence of the oxyanion nature of the electrolyte on the corrosion/passivation behaviour of nickel. *Corrosion Science*, 2013, vol. 74, pp. 187-193. 10.1016/j.corsci.2013.04.042 . hal-00875485

HAL Id: hal-00875485

<https://hal.science/hal-00875485>

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To link to this article : DOI:10.1016/j.corsci.2013.04.042
URL : <http://dx.doi.org/10.1016/j.corsci.2013.04.042>

<p>To cite this version : Trompette, Jean-Luc and Massot, Laurent and Vergnes, Hugues. <i>Influence of the oxyanion nature of the electrolyte on the corrosion/passivation behaviour of nickel</i>. (2013) Corrosion Science, vol. 74 . pp. 187-193. ISSN 0010-938X</p>
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Influence of the oxyanion nature of the electrolyte on the corrosion/passivation behaviour of nickel

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A B S T R A C T

The electrochemical behaviour of nickel in the presence of various electrolyte solutions at 0.1 mol/L concentration exhibits a distinction according to the oxyanion nature of the investigated anions. Passivity is achieved with oxyanions whereas it fails with anions not containing oxygen. SIMS and XPS measurements performed from isotopic and non isotopic KNO_3 electrolytes indicate that the oxygen and nitrogen atoms from nitrate oxyanions are incorporated into the passive film during anodic polarization and with evidence of a direct bonding between nitrogen and nickel surface.

Keywords:

- A. Nickel
- B. Polarization
- B. SIMS
- B. XPS
- C. Anodic films
- C. Pitting corrosion

1. Introduction

Some previous studies were shown to rationalize the influence of anion specificity on the corrosion/passivation behaviour of some valve metals such as aluminium, titanium and tantalum [1–3]. These metals are characterized by the presence of a natural passive oxide film with a thickness of a few nanometers (2–5 nm typically) which is formed spontaneously when they are exposed to oxidizing media (air, water). The resistance of valve metals against corrosion originates from the propensity of this passive film to regenerate sufficiently quickly and cohesively after an eventual breakdown.

The investigated anions were conveniently distinguished according to the sign of the viscosity B coefficient value between the kosmotropes with $B > 0$ and the chaotropes with $B < 0$. Once the hydrated anions are adsorbed on the surface of the passive film, they may be involved in a thinning process of the passive film through the formation of soluble salts or complexes with surface metallic cations. Although this thinning process is challenged with the concomitant pronounced repassivation (regeneration) of valve metals, the chaotrope anions that are able to dehydrate easily can penetrate into the passive film and thus initiate localized corrosion. At the contrary, passivity was found to occur with the kosmotrope anions that tend to preserve their surrounding hydration shell (the energetic dehydration contribution is too unfavourable);

so reflecting that in such conditions the thinning process could not overcompensate film regeneration of the valve metals [2].

It seems therefore interesting from a fundamental point of view to investigate whether the previous trends may be applied to other types of metals with different properties.

Owing to its recognized resistance against corrosion, which is a domain of high technological and economical importance, nickel has been used pure or as an alloying element. It has been the subject of a considerable amount of studies concerning its electrochemical behaviour in many electrolytes and at varying pH [4–30], together with the mechanisms of formation of passive films, their nature, structure and properties [31–47]. The thin air-formed passive film on nickel surface is highly defective and may be removed easily. It is not so cohesive and prone to regeneration as that for the valve metals. However according to various anodization treatments and different experimental conditions, the resulting anodic oxide films were found to exhibit excellent resistance to breakdown. Based on these studies, a duplex structure of the passive film is generally proposed with an inner layer of crystalline NiO with a thickness up to 1.2 nm, and an outer layer of amorphous $\text{Ni}(\text{OH})_2$ with a thickness up to 0.6 nm [48], although it has been reported that much thicker films may be obtained in specific conditions [34,40].

According to the Pourbaix diagram of nickel [49], this metal is naturally passive when the solution pH is greater than about 8 and its immunity is preserved when the applied electrical potential is lower than its equilibrium potential. When the solution pH is acid, neutral or weakly basic, nickel (Ni) is known to present often an active–passive transition when increasing the electrical poten-

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tial in many electrolyte solutions. After an activation region where the electrical current increases, the current exhibits a maximum (say a peak) before it decreases abruptly to remain nearly constant during a variable range of electrical potential, and it increases finally due to oxygen evolution and/or transpassive metal dissolution [8,13].

In this study, the electrochemical behaviour of nickel in the presence of various electrolytes has been investigated. The results were complemented by SIMS and XPS measurements from non isotopic and isotopic KNO_3 electrolytes to appreciate the eventual incorporation of oxygen and nitrogen atoms into the passive film.

2. Material and methods

All the salts used: sodium fluoride (NaF), sodium chloride (NaCl), sodium bromide (NaBr), potassium iodide (KI), sodium perchlorate (NaClO_4), potassium nitrate (KNO_3), sodium thiocyanate (NaSCN), sodium formate (NaHCO_2), sodium acetate (NaCH_3CO_2), sodium hydrogenophosphate (NaH_2PO_4), sodium sulfate (Na_2SO_4), were analytical grade products manufactured by Prolabo (France) or Sigma-Aldrich (France). Isotopic potassium nitrate ($\text{K}^{15}\text{N}^{18}\text{O}_3$, 15N-98%, 18O-95%) was purchased from Santa Cruz Biotechnology (USA).

Deionized water was taken as a solvent to prepare the electrolyte solutions at 0.1 mol/L concentration. The pH of the electrolyte solutions was measured with an electronic pH-meter (Hanna Instrument). When the pH of the original electrolyte solution was too basic, say around pH 8, droplets of the following acids were added to decrease the pH value of the corresponding electrolyte solution: fluoric acid (HF) solution at 40 wt.% (Prolabo) in the case of NaF electrolyte solution, formic acid (HCO_2H) solution at 98.5 wt.% (Prolabo) in the case of NaHCO_2 electrolyte solution, and acetic acid ($\text{CH}_3\text{CO}_2\text{H}$) solution at 99 wt.% (Prolabo) in the case of NaCH_3CO_2 electrolyte solution.

Small nickel plates were cut from a commercial Ni foil (99%, Goodfellow, UK) with a thickness of 0.5 mm to obtain rectangular shape (1.5 cm $\times$ 0.8 cm). Before any experiment, the plates were washed in acetone and rinsed with deionized water. Then, the plates were electropolished twice during 2 min in a 57% sulfuric acid solution at a 0.5 A/cm² current density. They were finally rinsed with deionized water and dried in air.

The electrochemical experiments were performed with a potentiostat (Radiometer Analytical S.A. Copenhagen, Tacussel DEA 332, potential range 0–8 V) coupled with a digital converter (Radiometer Analytical, IMT 102) and controlled by a PC running the electrochemical software (Radiometer Analytical, VoltaMaster 2). The electrochemical set up was constituted with a nickel plate as the working electrode and a large flat platinum plate as the auxiliary electrode. The plates were immersed at 1 cm depth in 50 mL of the studied solution. A mercurous sulfate electrode (MSE), Hg/HgSO₄/K₂SO₄ saturated solution, served as a reference electrode. All the reported potential values refer to this reference electrode.

Linear voltammograms were performed in the range –1 to +1 V/MSE with a 5 mV/s sweep rate under agitation at 200 rpm (magnetic stirrer) of the studied solution. The same device was used for chronoamperometric experiments where the current intensity was recorded as a function of time at an imposed electrical potential.

The voltammograms were performed at ambient temperature and repeated once to confirm the reliability of the electrochemical results.

For the SIMS and XPS measurements, linear voltammograms were performed on nickel plates from –1 to 0.7 V/MSE with a 5 mV/s sweep rate under agitation at 200 rpm (magnetic stirrer) in the studied electrolyte solution. The treated plates were thor-

oughly rinsed with deionised water and dried in air before they were analysed.

A Cameca IMS 4F6 apparatus was used for SIMS analysis. Sputtering was performed with a 2 keV cesium ion beam. The incident angle of the ion beam was 45° with respect to the sample surface. A square area with a 150 μm edge length was attacked by the beam and the 20% central area of the crater was analyzed. For SIMS analysis, the masses used were 16 (^{16}O), 18 (^{18}O), 72 ($^{58}\text{Ni}^{14}\text{N}$), 73 ($^{58}\text{Ni}^{15}\text{N}$). The natural isotopic abundancies are: 0.20% and 0.36% for ^{18}O and ^{15}N respectively [50].

A K-alpha apparatus (Thermo Scientific) was used for XPS analysis. The excitation source is a monochromatic ray Al K α (1486.6 eV). Binding energies are calibrated with respect to the C–C bond of C 1s at 284.4 eV. Etching was applied during 5 s with an argon ion beam at 1 keV. XPS measurements were first performed with untreated nickel sample that served as a blank of reference for further assignment of the peaks for the treated samples. The peaks corresponding to the binding energies of Ni 2p_{3/2} at 852.46 eV (76.48% at.), 856.40 eV (3.43% at.), 858.60 eV (11.94% at.) were detected, together with O 1s at 531.95 eV (8.15% at.).

After the chronoamperometric experiments, a 3CCD digital video camera, Panasonic NV-GS 120 (Crystal Engine), was used to take photographs of the plates.

3. Results and discussion

3.1. Comparative linear voltammograms

The anodic polarization of Ni in the presence of the studied electrolytes is reported in Figs. 1–3. For NaHCO_2 , NaCH_3CO_2 and NaF electrolytes, the pH of the prepared solution is too high so that Ni remains passive: the current density is very low and the active-passive transition (say the peak) is not observed. Indeed when

Fig. 1. Linear voltammograms with (a) Na_2SO_4 (thin curve), NaH_2PO_4 (thick curves) electrolytes at 0.1 mol/L concentration and with (b) KNO_3 (thin curve), NaClO_4 (thick curve) electrolytes at 0.1 mol/L concentration.

Fig. 2. Linear voltammograms with (a) NaHCO_2 and (b) NaCH_3CO_2 electrolytes at 0.1 mol/L concentration at original pH value (thick curves) and modified pH value (thicker curves).

Fig. 3. Linear voltammograms with (a) NaCl , NaBr (thick curve), KI , NaSCN electrolytes at 0.1 mol/L concentration and with (b) NaF electrolyte at 0.1 mol/L concentration at original pH value (thick curve) and modified pH value (thicker curve).

metallic nickel is immersed in sufficiently aqueous alkaline solution the spontaneous formation of a nickel (II) hydroxide passive layer, $\text{Ni}(\text{OH})_2$, may result [51]. To prevent such cases, few droplets

of the corresponding acid were added to decrease the solution pH value (see Section 2). The polarization curves at original and modified pH values have been superimposed in Fig. 2 for NaHCO_2 and NaCH_3CO_2 , and in Fig. 3 for NaF .

For Na_2SO_4 with original pH 6.2 (thin curve), and NaH_2PO_4 with original pH 4.6 (thick curves), see case a in Fig. 1, the behaviour is in accordance with the expected trends. As an indication, the two runs performed with NaH_2PO_4 electrolyte were plotted to appreciate the reproducibility of the results. Oxygen evolution is found to occur around 0.7 V/MSE. After the top of the peak, the steep decrease of the current density followed by the wide constant region indicates the establishment of passivity owing to the formation of the oxide film on the metal surface according to the oxidation reaction [4]:

For KNO_3 with original pH 5.5 (thin curve), and NaClO_4 with original pH 5.3 (thick curve), see case b in Fig. 1, the results are similar.

For NaHCO_2 , see case a in Fig. 2, and NaCH_3CO_2 , see case b in Fig. 2, the behaviour is of the same type as previously when the pH is decreased to allow the active-passive transition to occur, say from original pH 7.4 (thick curve) to 4.6 (thicker curve) for instance with NaHCO_2 , and from original pH 7.7 (thick curve) to 5.5 (thicker curve) for instance with NaCH_3CO_2 .

For these first six electrolytes where passivity is observed, the active-passive transition is located approximately around -0.4 V/MSE with a steep decrease of the current density after the top of the peak and the extent of the passive region is pronounced. The nickel plates remain bright and no sign of attack is observed.

For NaCl with original pH 5.4, NaBr with original pH 5.5 (thick curve), and KI with original pH 6.1, see case a in Fig. 3, the decrease of the anodic current after the top of the peak is not as sharp as that classically associated with the occurrence of passivity and the minimum current is still high just before the current density increases definitively, well before oxygen evolution takes place.

For NaSCN with original pH 5.6, see case a in Fig. 3, there is no active-passive transition. The current density increases continuously within the investigated potential range. A black deposit of nickel sulfide (NiS or Ni_3S_2) forms from the beginning on the surface [52]. The formation of sulfide has been assumed to result from the reaction of the metal with elemental sulfur originating from the decomposition of some thiocyanate anions at the nickel surface according to: $\text{SCN}^- = \text{S} + \text{CN}^-$ [53].

For these electrolytes (case a in Fig. 3), the observed linear increase of the current density is characteristic of a pure resistive system (ohmic regime). The resistance of the system was indeed found to correspond to that of the electrolyte solution. During this increase, intensive hydrogen bubbling occurs at the platinum plate and the pH becomes increasingly basic. As expected the plates have been pitted.

For NaF , see case b in Fig. 3, there is a significant influence of the solution pH. As expected, Ni remains passive in the as-prepared basic solution with original pH 9.7 (thick curve) whereas two maxima are observed when the pH is lowered to 5 (thicker curve). After the activation region, the current density decreases similarly as with the previous halides (without a wide constant region) before it increases up to the second maximum characterized by a steep decrease, and followed by a final increase due to oxygen evolution. The presence of this second maximum has been already studied; it was ascribed to the formation of a passivating NiF_2 layer [19,20].

As information, during the cathodic polarization of nickel in the presence of the electrolyte solutions a current density plateau is observed that corresponds to the reduction of dissolved oxygen.

3.2. Comparison of aggressive behaviours

Based on the previous results, the aggressiveness of NaSCN, NaBr, NaF at pH 5, and KNO₃ solutions has been inspected through chronoamperometric experiments. Whereas passivity was found to occur with the first six studied electrolytes, say the current density remained at a low level during a long range of potential before oxygen evolution at around 0.7 V/MSE, signs of attack were apparent with the other electrolytes where the current density increased continuously with the potential. It is thus pertinent to choose a potential value within this potential range. Chronoamperometric experiments were performed at 0.4 V/MSE electrical potential during 20 min. The corresponding curves are shown in Fig. 4. The involved valence z was determined according to the Faraday's law:

$$z = \frac{QM_{\text{Ni}}}{F\Delta m} \quad (2)$$

where Q is the amount of charge passed during electrolysis duration ($Q = \int i \, dt$ corresponds to the chronoamperometric curve area; it is calculated by the VoltaMaster 2 software), M_{Ni} is the atomic weight of nickel, F is the Faraday constant, Δm is the weight loss of a nickel plate.

The results are: $z = 2.21$, 2.07 and 2.04 for NaSCN, NaBr and NaF at pH 5 respectively. For KNO₃ no z value can be calculated since the weight of the Ni plate was unchanged. The obtained z values indicate a corrosion process releasing nickel II species in accordance with the oxidation reaction [7]:

Photographs of the corresponding nickel plates are shown in Fig. 5. In the case of NaSCN, the formation of the nickel sulfide black deposit does not prevent pitting to occur [52]. The presence of adsorbed sulfur was known to enhance metal dissolution by weakening the bonds between the metal atoms and to exert a poisoning effect by inhibiting the growth of an oxide passive film [54,55]. Pits are present with NaBr (see Fig. 5) whereas the plate is uniform with NaF at pH 5 although its aspect is dull, not as bright as it is observed with KNO₃ where no attack has occurred, as expected.

Among the halides, the attack of nickel by fluorides has been already reported to be different from the others (say chloride, bromide, iodide) [17]. Whereas a general corrosion process of the oxide film, through a uniform dissolution, was found to occur with fluoride, a localized attack of the passive oxide film, corresponding to a pitting corrosion process, was obtained with the other halides [27]. The invoked argument to interpret this discrepancy was ascribed to the decreasing magnitude of the stability constants, from fluoride to iodide, of the resulting soluble complexes with the surface metallic cations during the thinning process of the passive

Fig. 4. Chronoamperometric curves at 0.4 V/MSE for NaSCN, NaBr, NaF at pH 5 and KNO₃ electrolytes at 0.1 mol/L concentration.

Fig. 5. Photograph of nickel plates after the chronoamperometric experiments.

layer [56]. Interestingly, the concept of the categorization of anions offers the opportunity to interpret, in a complementary way, this distinction in the corrosion mechanism between the halides since fluoride is a kosmotrope anion whereas the others are chaotropes [1]. Once the halides are adsorbed on the surface of the passive layer, they participate to a thinning process of this film through the formation of soluble complexes. However, as the chaotrope halides such as chloride, bromide and iodide, are prone to loose their hydration shell, they may be also able to penetrate into the passive layer so that the attack is localized and therefore pitting is observed. As the fluoride anions tend to preserve their hydration shell, pitting is precluded [2]. The thinning process may thus be assumed to be widespread over the whole surface of the passive layer and the attack is then more uniform, as it is effectively observed.

Despite the breakdown of passive film of valve metals was found in the presence of the chaotrope nitrate (NO₃⁻) and perchlorate (ClO₄⁻) anions [1,2], passivity of nickel is observed with these two oxyanions whereas passivity breakdown occurs with the other chaotrope anions not containing oxygen (Cl⁻, Br⁻, I⁻, SCN⁻). With the tested kosmotrope anions (SO₄²⁻, H₂PO₄⁻, F⁻, HCO₂⁻, CH₃CO₂⁻), which are expected to be less aggressive, passivity due to an oxide film is preserved except in the case of fluoride which is among them the sole anion not containing oxygen. These observations related to the oxyanion nature of the studied electrolytes are somewhat unexpected and should deserve deeper investigations. If it is not a coincidence, this opens the question whether the oxyanions could contribute to passivate the nickel surface by their oxygen atoms, as it has been hypothesized in few studies in the past [15].

3.3. SIMS and XPS analysis

SIMS measurements of passive films elaborated on Ni from anodization treatments in the presence of H₂O solvent molecules enriched in isotopic oxygen ¹⁸O were useful to show the sequence of breakdown and repair events within the oxide film [42,48].

SIMS measurements were used here to determine whether the constitutive oxygen atoms from a representative oxyanion are detected into the passive film. For that purpose, linear voltammograms were performed on nickel plates from -1 to 0.7 V/MSE, say up to the end of the passive region before oxygen evolution (see case b in Fig. 1), with an aqueous solution of isotopic K¹⁵N¹⁸O₃ electrolyte and with an aqueous solution of non isotopic KNO₃ electrolyte, both at 0.1 mol/L concentration. The treated plates were analysed comparatively. The used isotopic electrolyte allowed investigating if nitrogen atoms were also present into

the passive film. However the signals of ^{14}N and ^{15}N were too unreliable, they decreased steeply from the beginning and remained at a very low intensity level. The response of the fragments Ni^{14}N and Ni^{15}N were then recorded. The comparative results are reported in Fig. 6.

The natural abundance of the ^{16}O and ^{18}O isotopes is 99.76% and 0.20% respectively [51]; the isotopic ratio ($^{16}\text{O}/^{18}\text{O}$) corresponds to 498.8, say about 500. For non isotopic KNO_3 electrolyte, see case a in Fig. 6, the ratio of the intensity at the top of the curves in the prime instants for the response of ^{16}O and ^{18}O corresponds nearly to 500, say the expected isotopic ratio, and this ratio remains constant during analysis. This can be estimated by the separation distance between the two curves. For isotopic $\text{K}^{15}\text{N}^{18}\text{O}_3$ electrolyte, see case b in Fig. 6, the response of ^{16}O is practically unchanged whereas that of ^{18}O is increased. At the top of the curves the ratio is about 105, say the separation distance is shorter than in case a, and the curves diverge from one another with time analysis, so reflecting that the separation distance tends to equal that in case a. This indicates that the proportion of ^{18}O is about 5 times greater in the film with isotopic KNO_3 than it is in the film with natural KNO_3 . This proves the presence of oxygen atoms from the NO_3^- oxyanion into the passive film. Moreover, the level of the response of the fragments Ni^{14}N and Ni^{15}N is observed to be inversed when comparing cases a and b in Fig. 6. This result suggests that nitrogen atoms originating from KNO_3 electrolyte are also present into the passive film.

XPS measurements were performed with a new nickel plate that was treated in the same conditions as previously with KNO_3 electrolyte, say linear voltammogram from -1 to 0.7 V/MSE. It was compared with the XPS analysis of a nickel plate treated with NaClO_4 electrolyte in the same conditions and where no nitrogen is expected to be detected. The results are reported in Fig. 7. The analysis before (thin curves) and after argon-ion etching (thick curves) have been superimposed.

Fig. 6. SIMS measurements for a nickel plate after passivation (a) in KNO_3 electrolyte and (b) in $\text{K}^{15}\text{N}^{18}\text{O}_3$ isotopic electrolyte.

Concerning the XPS analysis of O 1s in the passive film formed from KNO_3 electrolyte, the presence of two peaks has been already mentioned [13,48]. They correspond to the position of oxygen atom in NiO (529.6 eV) and Ni(OH)_2 (531.3 eV) [13,35]. As expected the peak corresponding to the inner layer NiO of the duplex structure is enhanced after etching (the outer layer being more altered). The analysis of N 1s from KNO_3 electrolyte shows the presence of two peaks corresponding to binding energies at 397.6 eV and 400 eV. The peak at 397.6 eV is accentuated after etching whereas that at 400 eV is significantly decreased and appears as a slight shoulder that can hardly be considered as a peak without great uncertainties. This reflects that the peak at 397.6 eV corresponds to nitrogen that is located sufficiently deep inside the passive film. The atomic percentage of N 1s in the film is found to be $2.0 \pm 0.5\%$. When the comparison is made with the analysis of N 1s from the passive film formed from NaClO_4 , see Fig. 7, the peak at 397.6 eV is absent so confirming that it corresponds indubitably to nitrogen originating from NO_3^- oxyanion. That at 400 eV is weakly present, so confirming it cannot be assigned to any KNO_3 origin, but it disappears after etching. It may be suggested that it corresponds to some inherent impurities that are easily removed by etching, owing to poor interactions with the metal surface.

Knowing that for N 1s in condensed KNO_3 a binding energy of 407.2 eV is expected [57], such a large shift of the binding energy to 397.6 eV suggests a direct bonding between nitrogen and the metal. According to the table of XPS N 1s binding energies for nitrogen compounds on transition metal surfaces given in reference [58], the peak at 397.6 eV can be effectively assigned to Ni—N bonding [59,60]. As an indication, the binding energy of Fe—N was reported to be 397.3 eV [61]; that for Zr—N and Ti—N were 397.7 eV and 397.0 eV, respectively [62].

The results inferred from SIMS and XPS measurements indicate that the oxygen and nitrogen atoms from NO_3^- oxyanions are incorporated into the passive film during anodic polarization. Moreover passivity was observed to occur with all the investigated oxyanions. These results support the assumption that the oxygen atoms of the oxyanions should contribute, to some extent, to participate to NiO film formation and/or to consolidate this passive film. The presence of the first maximum (say the peak) on the polarization curves reflects the concomitant occurrence of two antagonist effects during the increase of the electrical potential: the activation phase where metal dissolution occurs and the passivating phase where the oxide film builds on the surface. In conditions where the oxide film can develop over the whole surface without being damaged and even reinforced, passivity is then achieved: the current density decreases abruptly and remains at a low level. If the incipient oxide film is damaged by aggressive anions, the regeneration (repassivation) of this film on nickel is not as pronounced as that for valve metals and thus the current density increases again after the first maximum, so indicating that the substrate is attacked (through a general or pitting corrosion process). This is what was observed in the presence of anions not containing oxygen.

These results may provide useful information concerning the mechanism of action of inhibiting anions, which very often are oxyanions, when metal substrates are in the presence of aggressive species. It has been assumed that inhibitors can compete with aggressive anions on adsorption sites at the passive layer surface and/or they could be incorporated into the passive layer by plugging pores and flaws so allowing an enhanced stability against the attack of aggressive anions [15,22,63,64].

The existence of Ni—N bonding suggests that a decomposition of NO_3^- oxyanions at the nickel surface during anodic polarization may be envisaged (at least partially). It has to be noted that water itself may be seen as undergoing a decomposition process. Indeed, reaction (1) signifies there is a direct electrochemical reaction be-

Fig. 7. O 1s and N 1s photoelectron spectra for a nickel plate after passivation in KNO₃ electrolyte before (thin curves) and after argon-ion etching (thick curves); and N 1s photoelectron spectrum for a nickel plate after passivation in NaClO₄ electrolyte before (thin curve) and after argon-ion etching (thick curve).

tween Ni surface and water, and thus implicitly that Ni is able to get the oxygen atom off the water molecule to allow formation of the oxide film. This means that two hydrogen bonds should have to be broken. Knowing that the bond energy of O—H is 467 kJ/mol [65], the involved energy is significant. As an indication, the bond energy of N—O and N=O, that are present in NO₃[−] oxyanion, correspond to 201 and 607 kJ/mol respectively [65]. Moreover, thiocyanate anions (SCN[−]) were also observed to be decomposed at the nickel surface [53].

4. Conclusions

When comparing the shape of linear voltammograms in the presence of the investigated electrolytes, some general trends may be drawn. When the solution pH is such that Ni is not in a passive state (say pH < 8), passivity is found to be achieved only in the presence of oxyanions. In the other cases, the current density increases continuously from the beginning or after a poorly marked first maximum, so indicating that passivity has failed.

The concept of the categorization of anions helps to interpret the observed distinction in the corrosion mechanism of nickel according to the kosmotrope/chaotrope nature of the halides.

SIMS and XPS measurements performed with a representative nitrate oxyanion confirm the incorporation into the passive film of the constitutive oxygen and nitrogen atoms and with a direct bonding between nitrogen and nickel surface. The results would advocate for a decomposition process at the nickel surface during anodic polarization.

Acknowledgments

The authors are grateful to C. Armand, from the Département de Physique INSA Toulouse, for SIMS measurements; and to J. Esvan, from the CIRIMAT, for XPS characterizations.

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